



ELECTRONIC COPY

LG668407364
Report verification at igi.org



December 17, 2024

IGI Report Number **LG668407364**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **7.34 - 7.38 X 4.50 MM**

GRADING RESULTS

Carat Weight **1.50 CARAT**

Color Grade **E**

Clarity Grade **SI 1**

Cut Grade **IDEAL**

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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

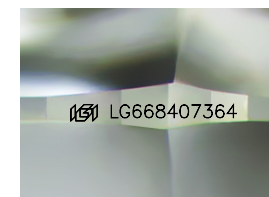
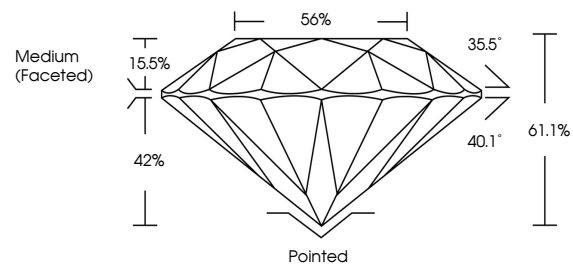
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **LG668407364**

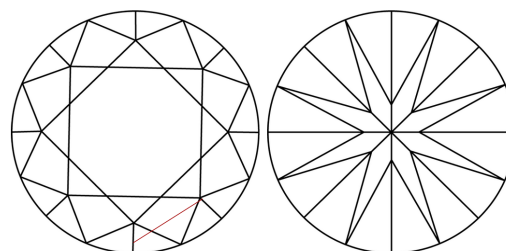
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

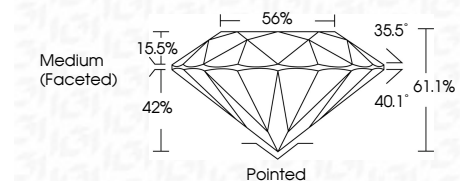
COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF WS¹⁻² VS¹⁻² SI¹⁻² I¹⁻³

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

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IGI



December 17, 2024	IGI Report No LG668407364	ROUND BRILLIANT	7.34 - 7.38 X 4.50 MM	1.50 CARAT	E	SI 1	IDEAL	61.1%	56%	Medium (Faceted)	Pointed	EXCELLENT	EXCELLENT	NONE	LG668407364
Carat Weight	Color Grade	Clarity Grade	Cut Grade	Depth	Table	Girdle	Polish	Symmetry	Fluorescence	Inscription(s)	Cutlet	Polish	Symmetry	Fluorescence	Inscription(s)
							EXCELLENT	EXCELLENT	NONE	LG668407364	Pointed	EXCELLENT	EXCELLENT	NONE	LG668407364

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